

Atty. Docket No. PPW06-560DS

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OCT 31 2006IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

Jae-Won HAN

: GROUP ART UNIT: 2812

APPLICATION NO: 10/751,172

FILED: DECEMBER 30, 2003

: EXAMINER: LEE, Kyoung

FOR: METHOD FOR MANUFACTURING
SILICIDE AND SEMICONDUCTOR
WITH THE SILICIDE

I hereby certify that this document is being facsimile transmitted to the USPTO or deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on October 31, 2006.

By:


Jennie HeatonAMENDMENT AND REQUEST FOR RECONSIDERATION UNDER 35 U.S.C. 132
AND 37 C.F.R. 1.111

Mail Stop AMENDMENT
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

SIR:

Responsive to the Office Action dated May 31, 2006, Applicant respectfully requests reconsideration of the above-identified application in view of the following amendments and remarks.